



Docket No.: 209284US99

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313



ATTORNEYS AT LAW

RE: Application Serial No.: 09/842,734

Applicants: Zhiyi YU, et al.

Filing Date: April 26, 2001

For: STRUCTURE AND METHOD FOR FABRICATING  
SEMICONDUCTOR STRUCTURES AND DEVICES  
USING BINARY METAL OXIDE LAYERS

Group Art Unit: 2811

Examiner: HU, S.

RECEIVED  
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TECHNOLOGY CENTER 2800

SIR:

Attached hereto for filing are the following papers:

**AMENDMENT**

**REQUEST FOR EXTENSION OF TIME (three-month)**

Our check in the amount of \$930.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

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